

Notice of References Cited	Application/Control No. 10/719,219	Applicant(s)/Patent Under Reexamination PHAM ET AL.	
	Examiner John L. Goff	Art Unit 1733	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-6,849,150	02-2005	Schmidt, Ronald P.	156/285
	B	US-5,939,007	08-1999	Iszczyszyn et al.	264/258
	C	US-4,981,753	01-1991	Ohta et al.	442/195
	D	US-5,648,424	07-1997	Miwa et al.	525/92D
	E	US-			
	F	US-			
	G	US-			
	H	US-			
	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N	JP 11207868 A	08-1999	Japan	TANABE et al.	B32B 15/08
	O					
	P					
	Q					
	R					
	S					
	T					

NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	English abstract for JP 11207868
	V	
	W	
	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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